

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2818  
Examiner: Mr. Dung Anh Le

In re PATENT APPLICATION of:

Applicant : Masao OKIHARA )  
Serial No. : 10/687,839 )  
Filed : October 20, 2003 )  
For : METHOD OF )  
FABRICATING A SILICON- )  
ON-INSULATOR DEVICE )  
WITH A CHANNEL STOP )  
Attorney Ref. : MAE 297 )

**SUPPLEMENTAL  
AMENDMENT**

*Please, enter  
this paper.  
DLE 10/13/05*

September 9, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is supplemental to the Amendment to the Amendment that was filed on  
August 3, 2005.

The fee of \$ Noae is being submitted concurrently. Should this remittance  
be accidentally missing, however, or should any additional fees be needed, the Director  
may charge such fees to our Deposit Account number 18-0002.

Please amend the above-identified application as specified on the following  
pages, and then reconsider the application in view of the Remarks that are presented  
thereafter.

**FEE ENCLOSED: \$**  
**Please charge any further**  
**fee to our Deposit Account**  
**No. 18-0002**